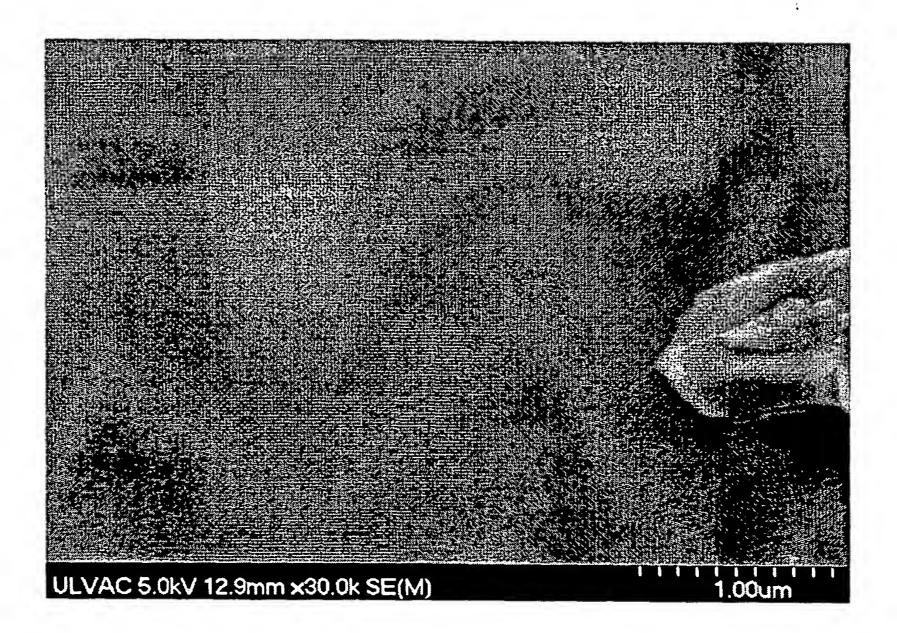
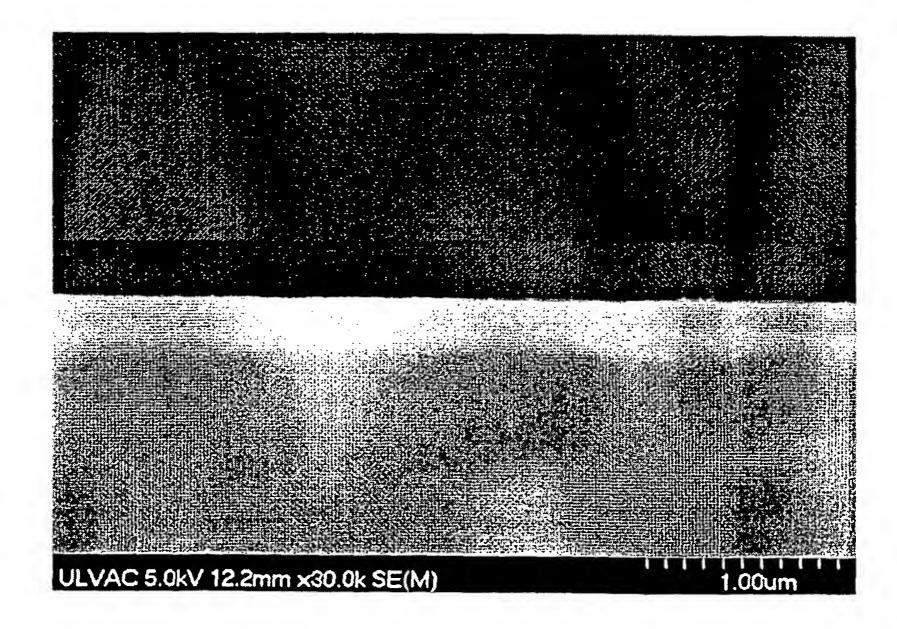
Title: METHOD FOR FORMING POROUS SILICA FILM

Inventor's Name: YAMADA et al. Application No.: New Docket No.: 101136-00094

## FIG.1

(a)

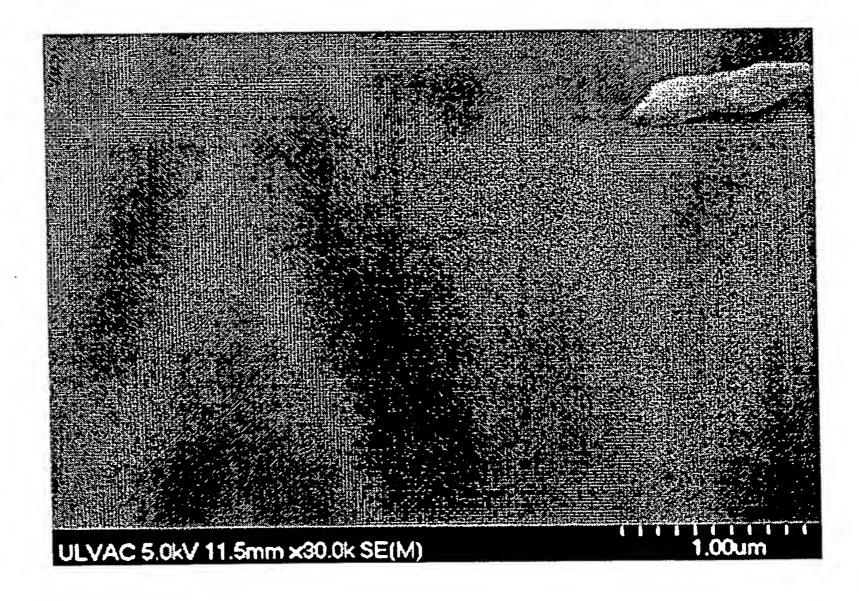


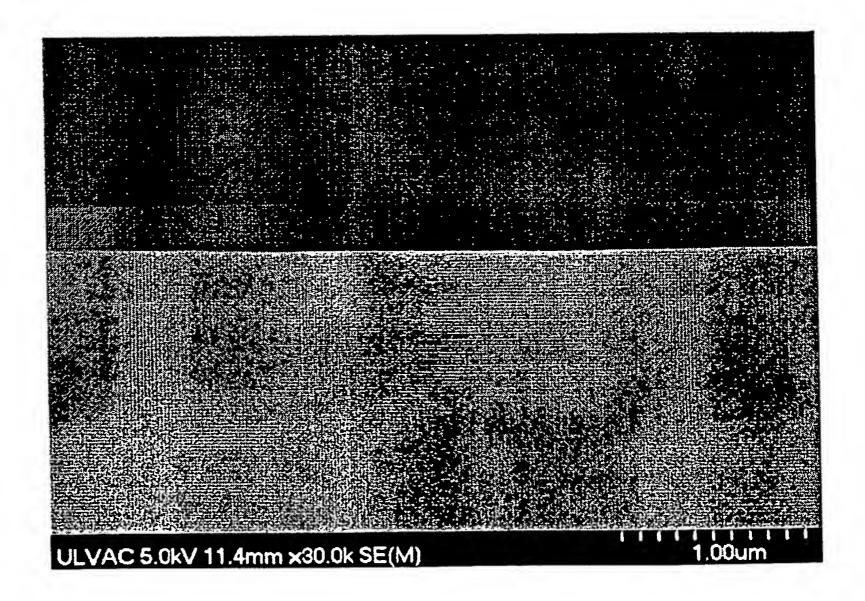


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Application No.: New
Docket No.: 101136-00094

## FIG.2

(a)



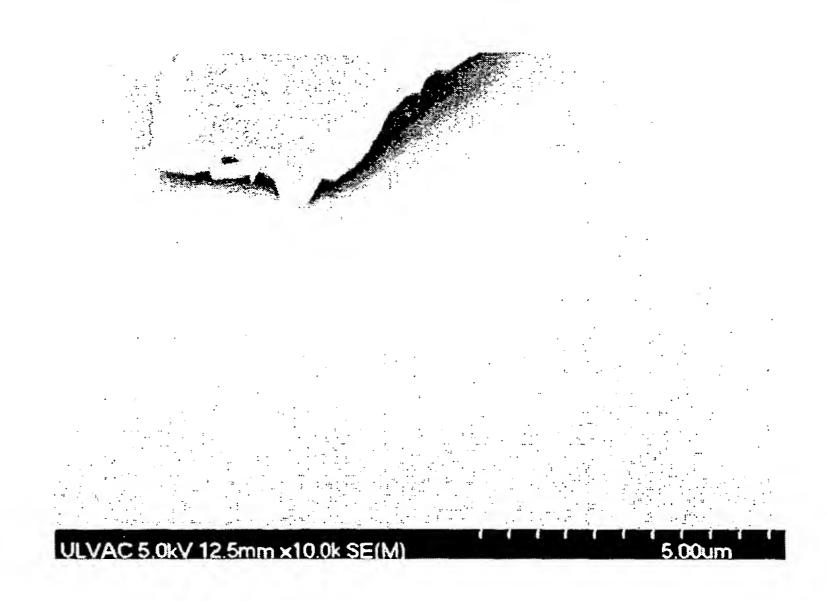


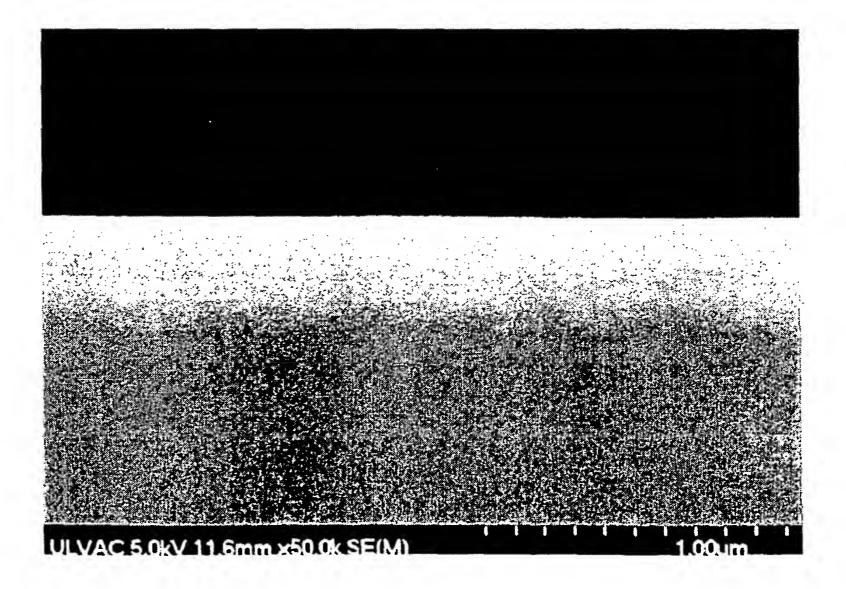
Title: METHOD FOR FORMING POROUS
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Application No.: New

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FIG.3

(a)





Title: METHOD FOR FORMING POROUS SILICA FILM

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FIG.4

(a)

